

## Electronic Patent Application Fee Transmittal

Application Number:	10813829			
Filing Date:	30-Mar-2004			
Title of Invention:		Method of plasma etch endpoint detection using a V-I probe diagnostics		
First Named Inventor/Applicant Name:	Armen Avoyan			
Filer:	Joseph A. Nguyen/Cassandra Reynolds			
Attorney Docket Number:	P1258/LMRX-P037			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
Petition-revive unintent. abandoned appl	1453	1	1540	1540
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	810	810
<b>Total in USD (\$)</b>				<b>2350</b>